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TO	EXAMINER NGAN NGO	JANUARY 22, 2004
	NAME	DATE
	U.S. PTO	571-273-1711 <i>PLW</i>
	COMPANY/FIRM	FAX #
	NUMBER OF PAGES INCLUDING COVER: 10	CONFIRM FAX: <input type="checkbox"/> YES <input type="checkbox"/> NO
FROM	Debbie Sierra	219723US-2S
	NAME	OUR REFERENCE
	703-412-1797	10/078,344
	DIRECT PHONE #	YOUR REFERENCE

**MESSAGE**

Pursuant to a telephone conversation, enclosed is a copy of the amendment filed November 10, 2003 (signed so as to be considered an original), along with the date-stamped filing receipt evidencing the filing thereof.

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✓ OSMM&N File No. 219723US-2S

Dept.: E/M

✓ Serial No. 10/078,344

By: EHK/DAB/dea

In the matter of the Application of: Hiijime NAGANO ET AL.

For: SEMICONDUCTOR DEVICE USING PARTIAL SOI SUBSTRATE AND  
MANUFACTURING METHOD THEREOF

✓ Due Date: 11/08/03

The following has been received in the U.S. Patent Office on the date stamped hereon:

- Dep. Acct. Order Form
- Letter/Cover
- Amendment



Docket No. 219723US-2S

IN RE APPLICATION OF: Hajime NAGANO ET AL.

SERIAL NO: 10/078,344

FILED: FEBRUARY 21, 2002

FOR: SEMICONDUCTOR DEVICE USING PARTIAL SOI SUBSTRATE AND MANUFACTURING METHOD THEREOF

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313RESPONSE UNDER 37 CFR 1.118-  
EXCELENTE PROCEDURE EXAMINING  
GROUP 2814

SIR:

Transmitted herewith is an amendment in the above-identified application.

No additional fee is required  
 Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.  
 Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
<b>TOTAL</b>	<b>8</b>	<b>MINUS</b>	<b>25</b>	<b>0</b>	<b>x \$18 =</b>	<b>\$0.00</b>
<b>INDEPENDENT</b>	<b>2</b>	<b>MINUS</b>	<b>3</b>	<b>0</b>	<b>x \$86 =</b>	<b>\$0.00</b>
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			<b>+ \$290 =</b>	<b>\$0.00</b>
					<b>TOTAL OF ABOVE CALCULATIONS</b>	<b>\$0.00</b>
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				<b>\$0.00</b>
		<input type="checkbox"/> Recordation of Assignment			<b>+ \$40 =</b>	<b>\$0.00</b>
					<b>TOTAL</b>	<b>\$0.00</b>

A check in the amount of \$0.00 is attached.  
 Credit card payment form is attached to cover the fees in the amount of \$0.00  
 Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.  
 If those papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

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DOCKET NO: 219723US-2S

RESPONSE UNDER 37 CFR 1.116-  
EXPEDITED PROCEDURE EXAMINING  
GROUP 2814

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

HAJIME NAGANO ET AL.

: EXAMINER: NGO, N.

SERIAL NO: 10/078,344

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FILED: FEBRUARY 21, 2002

: GROUP ART UNIT: 2814

FOR: SEMICONDUCTOR DEVICE  
USING PARTIAL SOI SUBSTRATE AND  
MANUFACTURING METHOD THEREOF

AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated August 8, 2003, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.